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P/2850-90

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re ~~Patent~~ Application of

New York, New York

Tomoko TAKAGI et al.

Date: January 25, 2006

Serial No.: 10/726,300

Group Art Unit: 1753

Filed: December 1, 2003

Examiner: ---

For: THIN FILM DEPOSITING METHOD AND APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art, together with a form listing the same for the convenience of the Examiner. A translation of the Office Action has been provided in lieu of a Statement of Relevancy of the present invention to the teachings of the teachings of the cited prior art.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 25, 2006

Max Moskowitz

Name of applicant, assignee or
Registered Representative

Signature
January 25, 2006

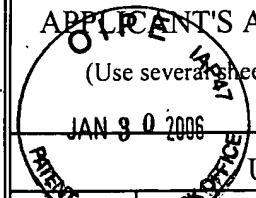
Date of Signature

Respectfully submitted,

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 APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/726,300		OFGS File No. P/2850-90		
		Applicant Tomoko TAKAGI et al.				
		Filing Date December 1, 2003		Group Art Unit 1753		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
	US-					
	US-					
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	US-					
	US-					
	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation
						Yes
	01-292830	11-1989	Japan			Abstract & Extract
	08-008204	01-1996	Japan			X
	2001-119049	04-2001	Japan			X
	09-213664	08-1997	Japan			X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
	English translation of Japanese Office Action dated December 6, 2005					
	submitted in lieu of a statement of relevancy of the present invention to the prior art					
	Untranslated Office Action issued by Japanese Patent Office on December 6, 2005 in					
	connection with corresponding Japanese application no. 2002-160676					
Examiner		Date Considered				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						